

VIA EFS
Docket No.: 199372003910
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naoki SHINDO et al.

Application No.: 10/779,397

Confirmation No.: 2798

Filed: February 13, 2004

Art Unit: 1792

For: SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Examiner: Alexander Markoff

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Madam:

INTRODUCTORY COMMENTS

This is in response to the non-final Office Action dated December 23, 2008, for which a response was due on March 23, 2009. Filed herewith is a Petition and fee for a 1 month extension of time, thereby extending the deadline for response to April 23, 2009. Accordingly, this response is timely filed. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.